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PATENT
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

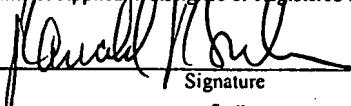
Applicants : Tetsuo YAMADA, et al.
Serial No. : 10/518,704
For : THIN FILM PIEZOELECTRIC RESONATOR, THIN FILM PIEZOELECTRIC DEVICE, AND MANUFACTURING METHOD THEREOF (As Amended)
Filing Date : December 17, 2004
Examiner : Mark Osborne Budd
Group Art Unit : 2834
Confirmation No. : 5674

O.K. to Enter
MBands 5-14-07

745 Fifth Avenue
New York, NY 10151
(212) 588-0800

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on April 30, 2007.

Donald R. Santucci, Reg. No. 28,988
(Name of Applicant, Assignee or Registered Representative)


Signature

April 30, 2007
Date of Signature

AMENDMENT UNDER 37 C.F.R. 121

AF
Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Final Office Action dated March 1, 2007, setting a three-month period for response ending June 1, 2007, Applicants respectfully request that the application be further amended as follows: